

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Confirmation No.: 2987

Takushi YOSHIDA, et. al.

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For: SUBSTRATE PROCESSING SYSTEM, SUBSTRATE PROCESSING
APPARATUS, PROGRAM AND RECORDING MEDIUM

VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

The information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application.

Respectfully submitted,

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